IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor(s):

Tue Nguyen 09/589,636

Appln. No.: Confirm. No.: 8595

Filed:

06/07/2000

Title: HIGH PRESSURE CHEMICAL VAPOR

TRAPPING SYSTEM

PATENT APPLICATION

Art Unit:

1725

Examiner:

Kevin P. Kerns

Customer No. 23910

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being transmitted by facsimile to the Commissioner for Patents, the United States Patent and Trademark Office, Processing Examining Group 1725 Facsimile No. (703) 872-9306, on September 3, 2004 Total number of pages transmitted 4 which includes the fax cover page.

Sheldon R. Meyer, Reg. No. 27,660 Signature Date: September 3, 2004

_(Attorney Signature)

TERMINAL DISCLAIMER TRANSMITTAL LETTER

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SEP 0 3 2004

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Sir:

The attached corrected Terminal Disclaimer Transmittal Letter and Terminal Disclaimer is to replace the version faxed to you on August 11, 2004. We thank you for your patience in this matter.

Transmitted with this communication in connection with the above-identified application are the following:

> TERMINAL DISCLAIMER TO OBVIATE A DOUBLE PATENTING REJECTION OVER A PRIOR PATENT

TERMINAL DISCLAIMER TO OBVIATE A PROVISIONAL DOUBLE PATENTING REJECTION OVER A PENDING SECOND APPLICATION

CERTIFICATE OF OWNERSHIP UNDER 37 C.F.R. §3.73(b)

A PETITION FOR AN EXTENSION OF TIME UNDER 37 C.F.R. §1.136.

-1-

Attorney Docket No.: TEGL-1191US0 MBasch/TEGL/1191US0/1191US0. 04.Terminal.Disc.ltr.wpd

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show	The fee associated associated the fee associated associ	ciated with this commun	ication pursuant to 37 C.F.R. §1.20(d) has been calculated as	
		A fee of \$110.00	(large entity) _ ✓ \$55.00 (small entity) is due.	
		A fee for extension of month(s) after the or	of time for response under 37 C.F.R. §1.136 filed within is due.	
		Small entity status o established.	f this application under 37 C.F.R. §1.9 and §1.27 has been	
	The total fee	required with this comr	nunication is \$ <u>55.00</u> and is to be paid as follows:	
		Please charge Deposicopy of this authorization	it Account No. 06-1325 in the amount of \$ <u>55.00</u> . A duplicate ation is enclosed.	
	A check in the amount of \$ is enclosed.			
✓	✓ The Commissioner is hereby authorized to charge any deficiencies or credit overpayme Account No. 06-1325. A duplicate copy of this authorization is enclosed.			
			Respectfully submitted,	
Date:	September 3,	2004	By: Sheldor R. Meyer Rog. No. 27,660	
Four E San Fr	LER MEYER I Imbarcadero Ce ancisco, Califor ione: (415) 362-	enter, Fourth Floor rnia 94111-4156		

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CONFIDENTIAL

TO:	Commissioner for Patents t	for Examiner Kevin Kerns	
	Art Unit 1725		
FAX NO.:	703-872-9306		
FROM:	Sheldon R. Meyer		
RE:	Application No. 09/589,636	1	
	Title: HIGH PRESSURE CH	HEMICAL VAPOR TRAPPING SYSTEM	
DATE:	August 27, 2004	Total Pages : 4	
		(Including Fax Cover Page)	
Original will f	ollow by mail: No		

Original will follow by mail: No

If you do not receive all of the pages, please call <u>Mary Beth Stone</u> at 415.362.3800.

ATTACHED:

- 1. Terminal Disclaimer (1 pg.)
- 2. Terminal Disclaimer Transmittal Letter (2 pgs.)

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